



PATENT  
Attorney Docket No.: 17620R-002600US  
Client Ref. No.: 900035US

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of:

TA-CHUNG WU *et al.*

Application No.: 10/668,454

Filed: September 22, 2003

For: **METHOD OF FORMING  
BOTTOM OXIDE LAYER IN  
TRENCH STRUCTURE**

Customer No.: 20350

Confirmation No.: 2352

Examiner: Khiem D. Nguyen

Technology Center/Art Unit: 2823

**PRELIMINARY AMENDMENT**

**MAIL STOP RCE**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Prior to examination of the above-referenced application, please enter the following amendments and remarks:

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 3 of this paper.

**Remarks/Arguments** begin on page 8 of this paper.